

INFORMATION DISCLOSURE
CITATION

Docket No.: 0094.072

Serial No.:

Inventor: James V.
Crivello

Examiner:

Filing Date:

GAU:

UNITED STATES PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
SMc	AA	3,457,193	07/22/69	Tinsley et al.	260	2	June 30, 1065
SMc	AB	3,415,794	10/10/68	Orth et al.	260	78.5	March 28, 1966
SMc	AC	5,463,084	11/31/95	Crivello et al.	549	214	February 1, 1993

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Int'l Class	Int'l Subclass	Translation	
							Yes	No

OTHER DOCUMENTS

(Including Author, Title, Date Pertinent Pages, Etc.)

SMc	CA	H.Sasaki and J.V.Crivello, "The Synthesis, Characterization, and Photoinitiated Cationic Polymerization of Difunctional Oxetanes", <i>Journal of Macromolecular Science-Pure Appl. Chem.</i> A29(10), 915-930 (1992).
SMc	CB	J.V. Crivello and H. Sasaki, "Synthesis and Photopolymerization of Silicon-Containing Multifunctional Oxetane Monomers", <i>Journal of Macromolecular Science-Pure Appl. Chem.</i> A30 (2&3) 173-187 (1993).
SMc	CC	J.V. Crivello and H. Sasaki, "Structure and Reactivity Relationships in the Photoinitiated Cationic Polymerization of Oxetane Monomers", <i>Journal of Macromolecular Science-Pure Appl. Chem.</i> A30 (2&3) 189-206 (1993).
SMc	CD	B. Falk et. al., "Monitoring Photopolymerization Reactions with Optical Pyrometry", <i>Journal of Polymer Science: Part A: Polymer Chemistry</i> , 41, 579-596 (2003).
SMc	CE	C. Decker et. al., "Light Intensity and Temperature Effect in Photoinitiated Polymerization", <i>ACS Symp. Ser.</i> 673, 63 (1997).
SMc	CF	Hiroshi Sasaki Toagosei Co. Ltd., "Oxetanes: Curing Properties in Photo-Cationic Polymerization", <i>RadTech Technical Proceedings</i> , 61-68 (2000)

SMc	CG	Bidali et. al., "Heat and UV – Ignited Frontal Polymerization of an Epoxy Resin", Poster from Presentation from Ischia, Italy, June 2003.	
EXAMINER: /Sanza McClendon/ (07/11/2006)		Date Considered	
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.			

SUPPLEMENTAL INFORMATION DISCLOSURE CITATION JAN 29 2005 CANCELLED JAN 13 2005 PATENT & TRADEMARK OFFICE	Docket No.: 0094.072	Serial No.: 10/700,318
	Inventor: James V. Crivello	Examiner: Aftergut, Jeff H.
	Filing Date: 10/31/03	GAU: 1733

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Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
SMc	AD	4,289,595	09/15/81	Tortorello	204		
SMc	AE	5,144,051	09/01/92	Kessel et al.	556		

UNITED STATES PATENT APPLICATION PUBLICATIONS

Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
SMc	BA	2001/036,591	11/01/2001	Ilg et al.	430		

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Int'l Class	Int'l Subclass	Translation	
							Yes	No

OTHER DOCUMENTS

(Including Author, Title, Date Pertinent Pages, Etc.)

SMc	CH	PCT Notification of Transmittal of the International Search Report and the Written Opinion of the International Searching Authority, or the Declaration, dated 11/24/2004.

EXAMINER: /Sanza Mcclendon/ (07/11/2006)

Date Considered

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.